



1731  
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**PATENT APPLICATION**

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Kazuhiro NAKAGAWA et al.

Group Art Unit: 1731

Application No.: 09/786,470

Examiner: C. Lopez

Filed: March 5, 2001

Docket No.: 108776

For: METHOD OF MANUFACTURING SILICA GLASS MEMBER AND SILICA GLASS  
MEMBER OBTAINED BY THE METHOD

**AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In reply to the June 16, 2003 Office Action, the shortened statutory period for reply  
being extended by the attached Petition for Extension of Time, please consider the following:

**Amendments to the Claims** as reflected in the listing of claims; and

**Remarks.**